

Client's ref.: TSMC2003-0128

Our ref.: 0503-9981-USf/dwwang

#### **ABSTRACT OF THE DISCLOSURE**

A pedestal supporting a substrate in a plasma chamber. The pedestal includes an insulating base, a conductive layer overlying the insulating base, and a ceramic cover incompletely  
5 covering the conductive layer. The conductive layer is covered when the pedestal supports the substrate.